

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT												
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE												
CONVEYING PARTY DATA													
<table border="1"><tr><th>Name</th><th>Execution Date</th></tr><tr><td>California Institute of Technology</td><td>10/05/2005</td></tr></table>	Name	Execution Date	California Institute of Technology	10/05/2005									
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California Institute of Technology	10/05/2005												
RECEIVING PARTY DATA													
<table border="1"><tr><td>Name:</td><td>National Science Foundation</td></tr><tr><td>Street Address:</td><td>4201 Wilson Blvd</td></tr><tr><td>Internal Address:</td><td>Room 1265</td></tr><tr><td>City:</td><td>Arlington</td></tr><tr><td>State/Country:</td><td>VIRGINIA</td></tr><tr><td>Postal Code:</td><td>22230</td></tr></table>	Name:	National Science Foundation	Street Address:	4201 Wilson Blvd	Internal Address:	Room 1265	City:	Arlington	State/Country:	VIRGINIA	Postal Code:	22230	
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<table border="1"><tr><th>Property Type</th><th>Number</th></tr><tr><td>Application Number:</td><td>11123884</td></tr></table>	Property Type	Number	Application Number:	11123884									
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Application Number:	11123884												
CORRESPONDENCE DATA													
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PATENT
REEL: 024413 FRAME: 0751

License to the United States Government

Invention Title: System and Method for Making Nanoparticles Using Atmospheric Pressure Plasma Microreactor

Inventors: R. Mohan Sankaran; Konstantinos P. Giapis; Richard C. Flagan; Dean Holunga

Patent Application Serial No: 11/123,884

US Filing/Issue Date: 5/4/2005

Grant/Contract Identification No: CTS-0317397 & CTS-0404353

Foreign Applications filed/intended in (countries):

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14 or FAR 52.227-11, which are included among the terms of the above-identified grant/contract award from the National Science Foundation. This document is confirmatory of:

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2. All other rights acquired by the Government by reason of the above identified grant/contract award and the laws and regulations which are applicable to the award.

The Government is here by granted an irrevocable power to inspect and make copies of the above-identified patent application.

California Institute of Technology
1200 E. California Boulevard
Pasadena, California 91125

Dated: October 5, 2005


Adam Cochran
The Intellectual Property Counsel

CIT File No: 4190

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